

**Notice of References Cited**

Application/Control No.

10/800,827

Applicant(s)/Patent Under  
Reexamination  
CHEN ET AL.

Examiner

Kezhen Shen

Art Unit

2609

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0050100 A1	03-2005	Chin, Yuan-Chang	707/104.1
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**NON-PATENT DOCUMENTS**

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